

Electronic Acknowledgement Receipt

EFS ID:	2862110
Application Number:	10511883
International Application Number:	
Confirmation Number:	4213
Title of Invention:	Apparatus and method for depositing thin film on wafer using remote plasma
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Attorney Docket Number:	YPL-0108
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Application Type:	U.S. National Stage under 35 USC 371

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement (IDS) Filed	US_IDS_Form__SB_08a.pdf	781945 ca186d6c23930950cc072856c4f487abdf1c124	no	4

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2	Foreign Reference	Foreign_Reference.pdf	459766 6485f52624c1c8210a9f105a4dc4202c0a0b1a	no	11
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Warnings:**Information:**

3	NPL Documents	Japanese_Office_Action.pdf	44159 6a508be0d4db5a882315521dc0b18b13081c0566	no	2
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4	Fee Worksheet (PTO-06)	fee-info.pdf	8222 8c6406708b3db1282213ca25eef536c1ab03c390	no	2
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